

Page 7, line 24, delete "FIGS. 24A-B are perspective and cross sectional views" and replace with ~~FIG. 24 is a~~ perspective view~~--~~.

Page 8, line 2, delete "a" and replace with --the--.

Page 8, line 2, delete "equivalent to that".

Page 21, line 20, add new paragraph ~~FIGS. 15A-D~~

illustrate the process for fabricating the series connected resonators of FIG. 13~~FIG. 15A~~ shows the first layer metalizations that form electrodes ~~M1, M3 and signal ground (MG1 and MG2 combined)~~ ^{M2, M4 and M5}. FIG. 15B shows the deposition of the piezoelectric material 30. FIG. 15C shows a second layer metalization that forms electrodes ~~M2, M4 and M5 (MG1 and MG2 combined)~~ ^{M1, M3 and MG1 and}. FIG 15D is a schematic view showing the relative locations of the six resonators within the monolithic implementation of the pi network.

Page 22, line 27, delete "lower" and replace with --upper--.

Page 22, line 27, delete "44" and replace with --42--.

Page 23, line 1, delete "lower" and replace with --upper--.

Page 23, line 14, delete "lower" and replace with --upper--.

Page 24, line 1, add new paragraph ~~FIGS. 20A-D~~ illustrate the process for fabricating the series connected resonators of ~~FIG. 19~~ ^{FIG. 20A} shows the first layer metalizations that form electrodes M1 and M3 and signal ground ~~(electrode MG)~~ ^{electrodes M2 and M4}. FIG. 20B shows the deposition of the piezoelectric material 30. FIG. 20C shows a second layer metalization that forms electrodes ~~M2, M3 and M5~~ ^{M1, M3 and MG}. FIG. 20D is a schematic view showing the relative locations of the four